

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 8, 2025

IGI Report Number

LG747581221

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

6.81 X 4.88 X 3.32 MM

GRADING RESULTS

Carat Weight

1.09 CARAT

Color Grade

E

Clarity Grade

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

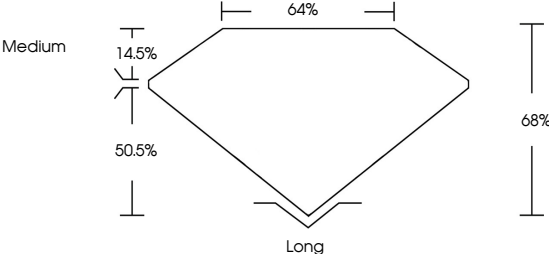
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Inscription(s)

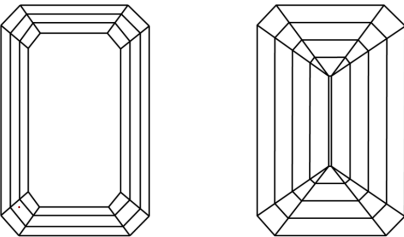
 LG747581221

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS




KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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
Symmetry

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Fluorescence

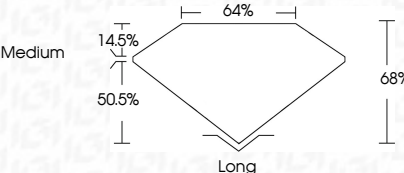
NONE



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EMERALD CUT

6.81 X 4.88 X 3.32 MM

Carat Weight

1.09 CARAT

Color Grade

E

Clarity Grade

VVS 1

Depth

50%

Table

64%

Girdle

Medium

Culet

Long

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

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Type IIa